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United States Patent [19]

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Wada et al.

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[54] **CONSOLE FOR MEASUREMENT SCANNER FOR SEMI-CONDUCTOR**

[56] **References Cited**

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Attorney, Agent, or Firm—Antonelli, Terry, Stout & Kraus

[**] Term: **14 Years**

[57] CLAIM

[21] Appl. No.: **25,208**

The ornamental design for a console for measurement scanner for semi-conductor, as shown.

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DESCRIPTION

[30] Foreign Application Priority Data

FIG. 1 is a front, top and right side perspective view of a console for measurement scanner for semi-conductor showing our new design;

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FIG. 2 is a front elevational view thereof;

[52] U.S. Cl. **D10/75**

FIG. 3 is a right side view thereof;

[58] Field of Search D10/46, 75; D13/123,

FIG. 4 is a rear elevational view thereof;

D13/162, 163; D14/102, 107; D24/186;

FIG. 5 is a left side view thereof;

348/135, 91, 94, 95, 130, 92, 142, 93, 162, 161,

FIG. 6 is a top plan view thereof; and,

125; 356/380, 386, 121, 237, 387; 360/9.1, 72.1;

FIG. 7 is a bottom plan view thereof.

382/34; 250/223 B

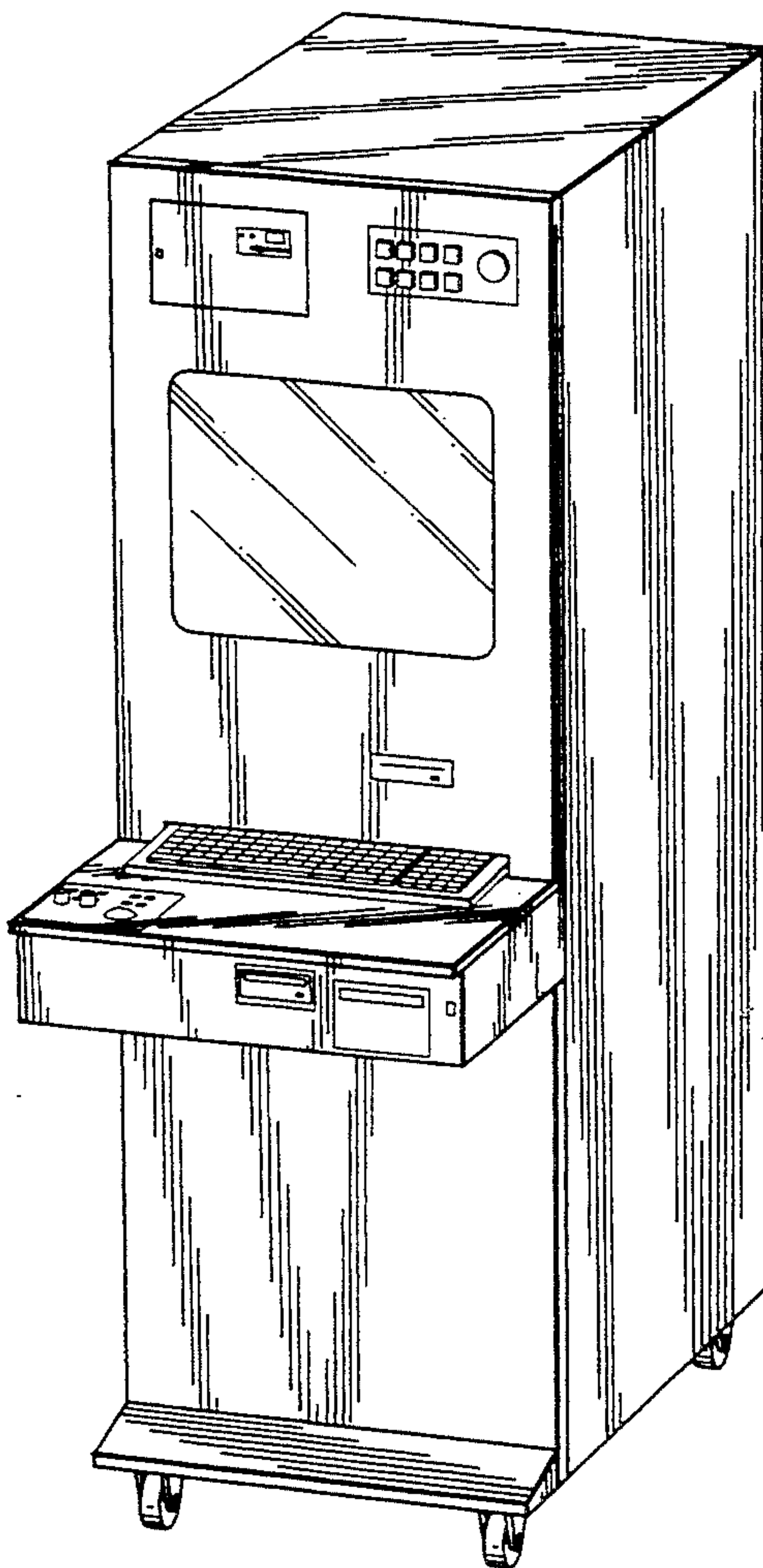


FIG. 7

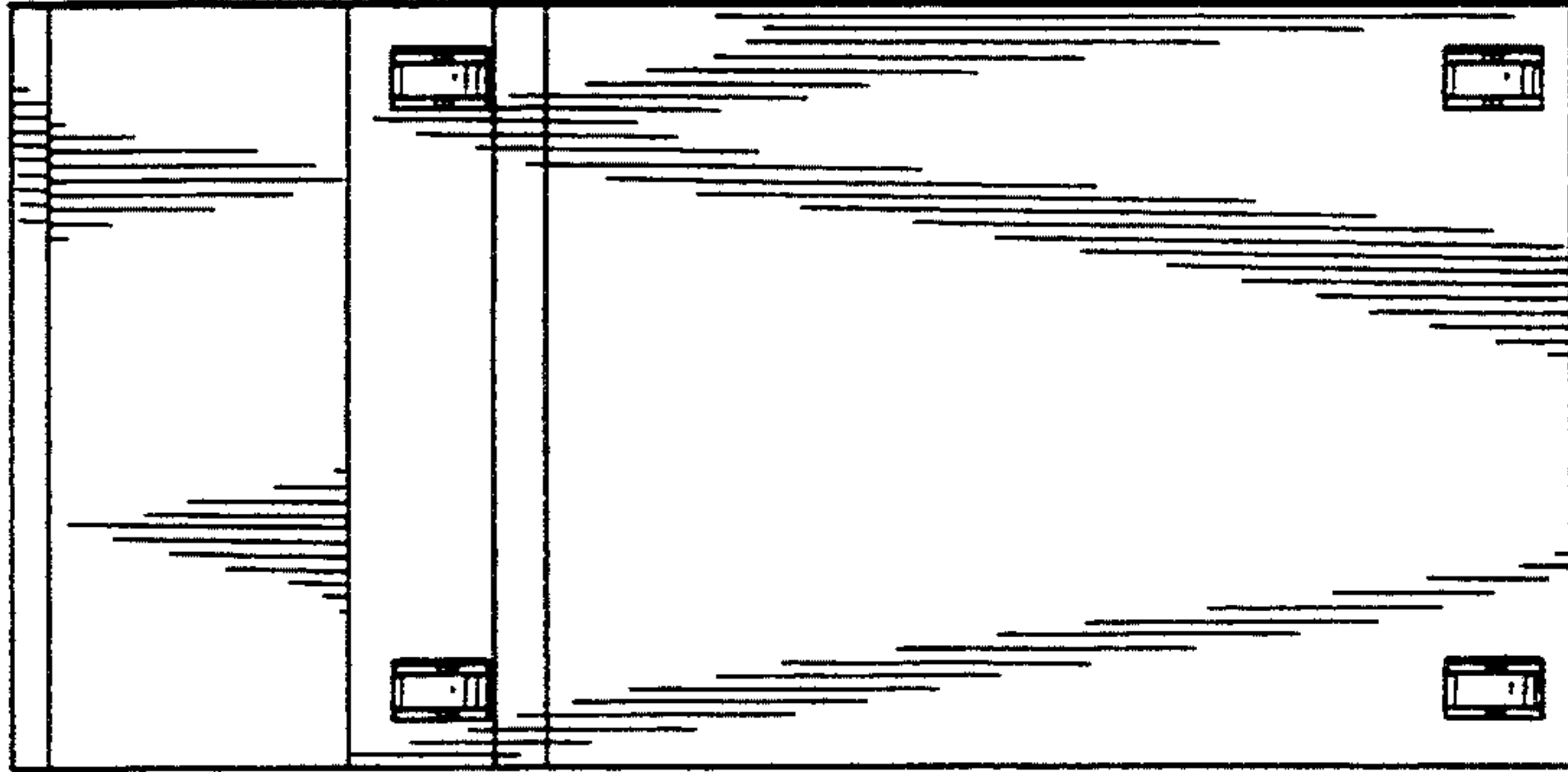


FIG. 6

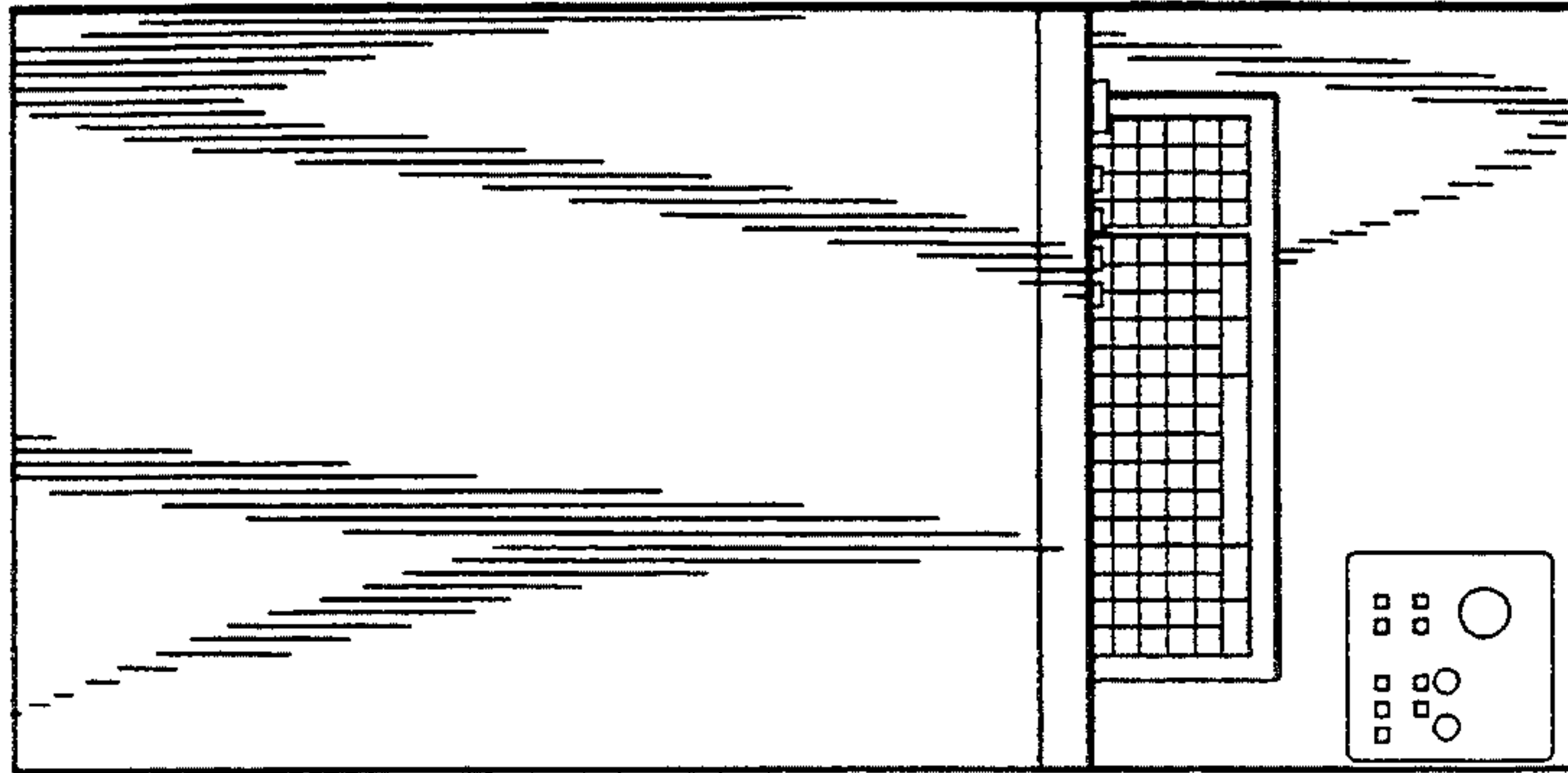


FIG. 5

